

Search Notes

Application/Control No.

10/770,090

Examiner

John Rivell

Applicant(s)/Patent under
Reexamination

SEMEIA, ROBERTO

Art Unit

3753

SEARCHED

Class	Subclass	Date	Examiner
137	512.15 825 854	8/14/2006	
128	200.29	8/14/2006	
128	204.26	8/14/2006	
128	204.27	8/14/2006	
128	205.24	8/14/2006	
128	207.12	8/14/2006	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
None	8/14/2006	